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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.	
10/630,571	07/29/2003	Heon-Heoung Leam	2522-025	8651	
75	90 09/02/2004	EXAM	EXAMINER		
	HNSON & McCOLL	LE, TH	LE, THAO P		
1030 S.W. Morrison Street Portland, OR 97205			ART UNIT	PAPER NUMBER	
Tornand, OK	77203	2818			
			DATE MAILED: 09/02/2004		

Please find below and/or attached an Office communication concerning this application or proceeding.

		Application	on No.	Applicant(s)			
Office Action Summers		10/630,57		LEAM ET AL.			
(	Office Action Summary	Examiner		Art Unit			
		Thao P. L		2818			
The MAILING DATE of this communication appears on the cover sheet with the correspondence address Period for Reply							
A SHORTENED STATUTORY PERIOD FOR REPLY IS SET TO EXPIRE 3 MONTH(S) FROM THE MAILING DATE OF THIS COMMUNICATION.  - Extensions of time may be available under the provisions of 37 CFR 1.136(a). In no event, however, may a reply be timely filed after SIX (6) MONTHS from the mailing date of this communication.  - If the period for reply specified above is less than thirty (30) days, a reply within the statutory minimum of thirty (30) days will be considered timely.  - If NO period for reply is specified above, the maximum statutory period will apply and will expire SIX (6) MONTHS from the mailing date of this communication.  - Failure to reply within the set or extended period for reply will, by statute, cause the application to become ABANDONED (35 U.S.C. § 133).  Any reply received by the Office later than three months after the mailing date of this communication, even if timely filed, may reduce any earned patent term adjustment. See 37 CFR 1.704(b).							
Status							
1)⊠ Re	sponsive to communication(s) filed on	16 August 2004					
2a) ☐ This action is <b>FINAL</b> . 2b) ☒ This action is non-final.							
•							
Disposition	of Claims						
4a) 5)□ Cla 6)⊠ Cla 7)□ Cla	4)  Claim(s) 1-20 is/are pending in the application.  4a) Of the above claim(s) is/are withdrawn from consideration.  5)  Claim(s) is/are allowed.  6)  Claim(s) 9-18 and 20 is/are rejected.  7)  Claim(s) is/are objected to.						
Application	Papers			J			
<ul> <li>9) The specification is objected to by the Examiner.</li> <li>10) The drawing(s) filed on is/are: a) accepted or b) objected to by the Examiner.  Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a).  Replacement drawing sheet(s) including the correction is required if the drawing(s) is objected to. See 37 CFR 1.121(d).</li> <li>11) The oath or declaration is objected to by the Examiner. Note the attached Office Action or form PTO-152.</li> </ul>							
Priority und	er 35 U.S.C. § 119						
<ul> <li>12) Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f).</li> <li>a) All b) Some * c) None of:</li> <li>1. Certified copies of the priority documents have been received.</li> <li>2. Certified copies of the priority documents have been received in Application No</li> <li>3. Copies of the certified copies of the priority documents have been received in this National Stage application from the International Bureau (PCT Rule 17.2(a)).</li> <li>* See the attached detailed Office action for a list of the certified copies not received.</li> </ul>							
2) Notice of 3) Information	References Cited (PTO-892) Draftsperson's Patent Drawing Review (PTO-94 on Disclosure Statement(s) (PTO-1449 or PTO/S		4) Interview Summary Paper No(s)/Mail Do 5) Notice of Informal F 6) Other:	ate	<sup>-</sup> O-152)		

### **DETAILED ACTION**

## **Priority**

1. Acknowledge is made of applicants' claim for foreign priority base on an application 2002-59554 filed in Korean on 09/30/2002.

#### Election/Restriction

2. Examiner confirms that Applicants elected to prosecute Claims 9-18, 20, and have withdrawn Claims 1-8, 19 without prejudice.

## Claim Rejections

## Claim Rejections - 35 USC § 103

- 3. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:
- (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.

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4. Claims 9-18, 20 are rejected under 35 U.S.C. 103(a) as being unpatentable over Applicant Admitted Prior Art (AAPA), and in view of Sato, U.S. Patent No. 6,232,179.

Regarding claims 9, 20, AAPA discloses a method of forming a non-volatile memory device comprising:

stack structures separated by a first space on a first area of the substrate and by a second space, wider than the first space, on a second area of the substrate adjacent to the first area (Fig. 1B);

forming a first spacers on sidewalls of the gate stack structures, the first gate spacers comprising an insulating material having a relatively low dielectric constant (oxide, Fig. 1B, page 3).

AAPA fails to disclose the step of forming a second gate spacers on the first spacers to fill the first spacer, the second gate spacers comprising an insulating material having a relatively high dielectric constant.

Sato discloses a method of forming gate electrode comprising the steps of forming first spacers 14 (Fig. 4) wherein the first spacer comprising a relatively low dielectric constant (silicon oxide, dielectric constant of about 4.2), and forming second spacers on the first spacers wherein the second spacers 15 (Fig. 4) comprising an insulating material having a relatively high dielectric constant (silicon nitride, dielectric constant of about 6.9).

It would have been obvious to one having ordinary skill in the art at the time the invention was made to form a second spacers made of relatively high dielectric constant of silicon nitride because the second spacers such as silicon nitride formed on the first spacers would prevent the first spacers and gate stack from silicide during salicidation because oxygen finds it difficult to penetrate silicon nitride and because silicon nitride has low stress, good coverage, low pinhole densities.

Regarding claim 10, Sato discloses the first gate spacers comprises an oxide and the second gate spacers comprise a nitride (abstract).

Regarding claims 11-14, it would have been obvious to one having ordinary skill in the art that the thickness of the first and second spacers, the pressure used to form the spacers would have been optimum or working ranges to one having skill in the art. The selection of such parameters such as energy, concentration, temperature, time, molar fraction, depth, thickness, etc., would have been obvious and involve routine optimization which has been held to be within the level of ordinary skill in the art. "Normally, it is to be expected that a change in energy, concentration, temperature, time, molar fraction, depth, thickness, etc., or in conbination of the parameters would be an unpatentable modification. Under some circumstances, however, changes such as these may impart patentability to a process if the particular ranges claimed produce a new and unexpected result which is different in kind and not merely degree from the results of the prior art ... such ranges are termed "critical ranges and the

applicant has the burden of proving such criticality.... More particularly, where the general conditions of a claim are disclosed in the prior art, it is not inventive to discover the optimum or workable ranges by routine experimentation." *In re Aller 105 USPQ233*, 255 (CCPA 1955). See also In re Waite 77 USPQ 586 (CCPA 1948); In re Scherl 70 USPQ 204 (CCPA 1946); In re Irmscher 66 USPQ 314 (CCPA 1945); In re Norman 66 USPQ 308 (CCPA 1945); In re Swenson 56 USPQ 372 (CCPA 1942); In re Sola 25 USPQ 433 (CCPA 1935); In re Dreyfus 24 USPQ 52 (CCPA 1934).

Regarding claims 15-18, Sato discloses the step of etching the second insulating layer to form second spacers and AAPA discloses wherein the gat stack structure is formed by stacking a tunnel dielectric layer, a floating gate, an integrate dielectric layer, a control gate, and control gate comprises polysilicon layer and metal silicide layer consisting of CoSi2, TiSi2, or NiSi2 (Pages 1-2).

5. When responding to the office action, Applicants' are advice to provide the examiner with the line numbers and page numbers in the application and/or references cited to assist the examiner to locate the appropriate paragraphs.

A shortened statutory period for response to this action is set to expire 3 (three) months and 0 (zero) day from the day of this letter. Failure to respond within the period for response will cause the application to become abandoned (see M.P.E.P 710.02(b)).

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#### Conclusion

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6. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Thao P. Le whose telephone number is 571-272-1785. The examiner can normally be reached on M-T (7-6).

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, David Nelms can be reached on 571-272-1787. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Thao P. Le Examiner Art Unit 2818